

## **A review on the p-type transparent Cu-Cr-O delafossite materials**

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## **Table SI**

Compilation of optoelectronic properties reported in literature for various  $ABO_2$  delafossite materials

The columns depicts (if reported within the article): First Author, Journal, Year, Synthesis Method; Material; Dopant; Dopant level; Electrical conductivity at room temperature; Direct or/and indirect band gap; carrier concentration; carrier mobility; Seebeck coefficient; Activation energy; thin film's thickness; Average optical transmission.

List of abbreviations for the deposition techniques:

**ALD** - Atomic Layer Deposition

**Comb.** – Combustion

### **Crystal Growth**

**CSD** - Chemical Solution Deposition

**CVD** - Chemical Vapour Deposition

**ER** - Exchange Reaction

**HT** – Hydrothermal

**MR** – Metathesis Reaction

**MS** - Magnetron Sputtering

**OPERE** - Oxygen Plasma Enhanced Reactive Evaporation

**PLD** - Pulsed Laser Deposition

**SG** - Sol-gel

**SS** – Solid State

**Th. Co.** - Thermal Co-evaporation

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
W. C. Sheets Inorg. Chem. 2008 HT	AgAlO <sub>2</sub>	-	-	9.00E-3	3.6	-	-	-	-	-	-	-
D. B. Rogers Inorg. Chem. 1971 SS	AgCoO <sub>2</sub>	-	-	6.67E-5	-	-	-	-	-	0.11	-	-
J. Tate Thin Solid Films 2002 MS	AgCoO <sub>2</sub>	-	-	2.00E-1	4.15	-	-	-	220	0.07	150	40-60
S. Ajimsha Thin Solid Films 2007 PLD	AgCoO <sub>2</sub>	-	-	8.77E-4	3.89	-	-	-	230	-	200	55
D. Xiong J. Alloys Compd. 2015 HT	AgCrO <sub>2</sub>	-	-	2.22E-6	3.32	-	4.33E11	-	-	-	-	60-75
R. Nagarajan Int. J. Inorg. Mater. 2001 SS	AgCrO <sub>2</sub>	-	-	1.40E-6	-	-	-	-	-	-	-	-
	AgCrO <sub>2</sub>	Mg	0.05	5.6E-5	-	-	-	-	-	-	-	-
R. Wei J. Mater. Chem. C 2017 SG	AgCrO <sub>2</sub>	Mg	0.12	6.77E-2	-	-	-	50	-	0.154	120	55
D. B. Rogers Inorg. Chem. 1971 SS	AgFeO <sub>2</sub>	-	-	3.33E-8	-	-	-	-	-	0.7	-	-



First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
W. C. Sheets Inorg. Chem. 2008 HT	AgScO <sub>2</sub>	-	-	4.00E-2	3.8	-	-	-	-	-	-	-
		-	-	9.00E-2	-	-	2.8E17	-	-	0.27	500	-
A.N. Banerjee Sol. Energy Mater. Sol. Cells 2005 MS	CuAlO <sub>2</sub>	-	-	1.60E-1	-	-	4.5E17	-	-	0.245	500	-
		-	-	3.90E-1	-	-	1.2E18	-	-	0.196	500	-
		-	-	1.40E-2	-	-	-	-	-	0.325	500	-
A. N. Banerjee Thin Solid films 2003 MS	CuAlO <sub>2</sub>	-	-	8.00E-2	3.66	2.1	-	-	128	0.26	700	-
B. L. Stevens J. Vac. Sci. Technol., A 2011 MS	CuAlO <sub>2</sub>	-	-	1.83E0	3.9	-	5E19	0.03	-	0.27	185	75
B. J. Ingram Chem. Mater. 2004 SS	CuAlO <sub>2</sub>	-	-	3.00E-2	-	-	1.20E21	8.9E-3	670	-	-	-
B. J. Ingram Chem. Mater. 2004 HT	CuAlO <sub>2</sub>	-	-	2.00E-1	-	-	3.8E21	-	-	-	-	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
CT. Su J. Cryst. Growth 2011 MS	CuAlO <sub>2</sub>	-	-	1.01E0	3.3	-	-	-	-	0.285	150	70
F.A. Benko J. Phys. Chem. Solids 1984 SS	CuAlO <sub>2</sub>	-	-	1.70E-3	-	1.65	1.1E19	1E-4	670	.	-	-
H. Gong Appl. Phys. Lett. 2000 CVD	CuAlO <sub>2</sub>	-	-	2.00E0	3.75	-	2.6E19	0.5	-	0.12	250	-
H. Kawazoe MRS Bull. 2000 PLD	CuAlO <sub>2</sub>	-	-	9.50E-1	3.5	-	1.3E17	0.13	183	0.2	500	80
	CuAlO <sub>2</sub>	-	-	4.00E-2	3.43	-	4.99E16	5	-	-	450	-
K.R. Murali Mater. Sci. Semicond. Process. 2013 SG	CuAlO <sub>2</sub>	-	-	5.00E-2	3.6	-	4.16E16	7.5	-	-	200-450	-
	CuAlO <sub>2</sub>	-	-	1.00E-1	3.68	-	5.94E16	10.5	-	-	200-450	-
	CuAlO <sub>2</sub>	-	-	5.00E-1	3.75	-	2.08E17	15	-	-	200	75
M. Ohashi J. Am. Ceram. Soc. 2001 SG	CuAlO <sub>2</sub>	-	-	4.00E-3	-	-	-	-	-	-	1100	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
N. Daichakomphy J. Phys. Chem. Solids 2019 SS	CuAlO <sub>2</sub>	Fe	0.1	5.37E-1	-	-	8.09E17	4.149	-	-	-	-
	CuAlO <sub>2</sub>	Fe	0.1	5.77E-1	-	-	9.08E17	3.97	-	-	-	-
RS. Yu Thin Solid films 2012 MS	CuAlO <sub>2</sub>	-	-	4.12E-3	3.26	-	-	-	-	-	460	-
	CuAlO <sub>2</sub>	-	-	4.31E-3	3.33	-	-	-	-	-	460	-
S. Götzendörfer Thin Solid Films 2009 SG	CuAlO <sub>2</sub>	-	-	1.43E-3	-	-	-	-	440	-	530	65
S. Gao Nanotechnology 2003 MR	CuAlO <sub>2</sub>	-	-	2.4E0	3.75	-	5.4E18	3.6	-	0.14	420	55
Y. Wang Chem. Vap. Deposition 2000 CVD	CuAlO <sub>2</sub>	-	-	7.31E0	3.75	-	4.51E19	2.1	-	-	120	45
	CuAlO <sub>2</sub>	-	-	1.60E+1	3.6	-	9.19E19	2.29	-	-	120	52
	CuAlO <sub>2</sub>	-	-	1.68E+1	3.64	-	1.64E20	1.56	-	-	120	52

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
Y. Wang Chem. Vap. Deposition 2000 CVD	CuAlO <sub>2</sub>	-	-	1.71E+1	3.67	-	1.17E20	1.96	-	-	120	52
C. Ruttanapun J. Appl. Phys. 2013 SS	CuBO <sub>2</sub>	-	-	4.12E-4	3.6	-	-	-	-	0.58	-	-
K. L. Sanal Mater. Sci. Eng., B 2014 MS	CuBO <sub>2</sub>	-	-	1.10E-1	3.2	-	-	-	-	-	150	-
Michael Snure Appl. Phys. Lett 2007 PLD	CuBO <sub>2</sub>	-	-	1.65E0	4.5	2.2	1E17	100	-	-	200	85
D. B. Rogers Inorg. Chem. 1971 SS	CuCoO <sub>2</sub>	-	-	5.00E-6	-	-	-	-	-	0.2	-	-
M. Beekman J. Alloys Compd. 2009 MR	CuCoO <sub>2</sub>	-	-	2.00E-3	0.4	-	-	-	-175	0.2	-	-
A. Barnabé, J. Mater. Chem. C, 2015 MS	CuCrO <sub>2</sub>	Mg	0.03	2.00E-3	-	-	5.19E17	2.530	804	-	100	-
	CuCrO <sub>2</sub>	Mg	0.03	1.78E+1	-	-	1.09E21	0.074	140	-	100	54.2
	CuCrO <sub>2</sub>	Mg	0.03	3.46E+1	-	-	8.07E20	0.408	167	-	100	-



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A. Barnabé, J. Mater. Chem. C, 2015 MS	CuCrO <sub>2</sub>	Mg	0.03	3.78E+1	-	-	1.32E21	0.192	122	-	100	65.4
	CuCrO <sub>2</sub>	Mg	0.03	5.22E+1	-	-	1.18E21	0.163	133	-	100	68.7
	CuCrO <sub>2</sub>	Mg	0.03	5.25E+1	3.3	-	1.34E21	0.155	121	0.055	100	63.3
	CuCrO <sub>2</sub>	Mg	0.03	6.43E+1	-	-	1.42E21	0.103	116	-	100	60.1
A. C. Rastogi, J. Appl. Phys. 2008 Spray	CuCrO <sub>2</sub>	Mg	0.03	2.00E-1	3.14	2.79	2.1E19	0.014	-	0.22	305	70
	CuCrO <sub>2</sub>	Mg	0.07	1.00E0	3.08	2.58	1.2E19	0.25	70	0.22	155	80
CH. Sun Ceram. Int. 2016 MS	CuCrO <sub>2</sub>	-	-	2.88E-2	3.08	-	4.7E17	0.39	-	-	-	61.8
	CuCrO <sub>2</sub>	-	-	3.64E-2	-	-	2.85E18	0.18	-	-	173	-
	CuCrO <sub>2</sub>	-	-	6.79E-2	3.13	-	1.42E18	0.3	-	-	-	-



First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
Da Li Vacuum 2010 PLD	CuCrO <sub>2</sub>	-	-	1.10E-2	3.2	-	-	-	-	-	134	60
	CuCrO <sub>2</sub>	-	-	1.50E-2	3.2	-	-	-	-	-	57	55
	CuCrO <sub>2</sub>	-	-	3.30E-1	3.2	-	-	-	-	-	127	60
DC. Tsai J. Mater. Res. Technol. 2018 MS	CuCrO <sub>2</sub>	-	-	3.60E-2	-	-	2.63E18	0.086	-	-	315	17.74
	CuCrO <sub>2</sub>	-	-	9.50E-2	-	-	3.39E18	0.176	-	-	212.8	37.17
	CuCrO <sub>2</sub>	-	-	1.77E-1	-	-	3.79E18	0.292	-	-	170.6	51.28
	CuCrO <sub>2</sub>	-	-	1.95E-1	3.18	-	4.02E18	0.303	-	-	166.9	58.31
E. Norton AIP Adv. 2018 Spray	CuCrO <sub>2</sub>	-	-	2.00E+1	-	2.4	2.50E22	0.006	-	0.2	90	-
F.A. Benko Mater. Res. Bull. 1986 SS	CuCrO <sub>2</sub>	Ca	0.05	1.00E-2	-	1.28	-	-	1210	-	-	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G</sub> D (eV)	E <sub>G</sub> I (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
F. Lin J. Alloys Compd. 2013 PLD	CuCrO <sub>2</sub>	-	-	1.78E0	3.17	-	1.40E18	7.7	-	0.11	26	75
	CuCrO <sub>2</sub>	Fe	0.05	2.53E0	3.12	-	2.52E18	6.27	-	0.067	36	72
	CuCrO <sub>2</sub>	Fe	0.1	5.56E-3	3.08	-	6.51E18	5.32	-	0.064	38	68
	CuCrO <sub>2</sub>	Fe	0.15	2.78E+1	3.05	-	4.09E19	4.2	-	0.04	52	65
G. Dong Appl. Surf. Sci. 2012 MS	CuCrO <sub>2</sub>	-	-	8.00E-2	3.05	-	4.5E18	0.11	-	0.035	280-300	70
	CuCrO <sub>2</sub>	-	-	1.80E-1	3.07	-	8.7E18	0.14	-	0.035	280-300	70
	CuCrO <sub>2</sub>	-	-	1.10E0	3.13	-	3E19	0.25	-	0.035	280-300	70
	CuCrO <sub>2</sub>	-	-	1.70E+1	3.19	-	1.4E20	0.81	-	0.035	280-300	70
HY. Chen Appl. Surf. Sci 2013 SG	CuCrO <sub>2</sub>	-	-	1.10E-3	2.95	-	2.8E14	25	-	0.285	190	45-55

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
HY. Chen Appl. Surf. Sci 2013 SG	CuCrO <sub>2</sub>	-	-	3.20E-3	2.9	-	3.8E15	5.3	-	-	190	45-55
	CuCrO <sub>2</sub>	-	-	4.40E-3	3.03	-	5.9E15	4.7	-	0.275	190	60
	CuCrO <sub>2</sub>	-	-	1.60E-1	3.06	-	1.8E16	56	-	0.18	210	60
HY. Chen, ECS J. Solid State Sci. Technol. 2013 SG	CuCrO <sub>2</sub>	-	-	2.00E-2	3	-	1.3E17	0.96	-	-	150-180	55-65
	CuCrO <sub>2</sub>	-	-	2.30E-2	3.05	-	1.9E17	0.76	-	-	180	60
	CuCrO <sub>2</sub>	-	-	3.80E-2	-	-	1.7E17	1.4	-	-	-	-
HY. Chen Surf. Coat. Technol 2013 SG	CuCrO <sub>2</sub>	-	-	1.50E-1	3	-	1.7E18	0.56	20	-	190	50-55
	CuCrO <sub>2</sub>	Zn	0.01	2.60E-1	3.05	-	2.15E18	0.76	40	-	220	50
	CuCrO <sub>2</sub>	Zn	0.03	4.70E-1	3.05	-	3.2E18	0.92	113	-	205	50

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
HY. Chen Appl. Surf. Sci. 2012 SG	CuCrO <sub>2</sub>	-	-	2.70E-2	3.08	-	2.8E13	3.2	230	-	125	66
Hui Sun J. Phys. D : Appl. Phys. 2016 MS	CuCrO <sub>2</sub>	Mg	0.07	2.74E-1	3.12	-	-	-	-	-	370	54
I. Sinnarasa Nanomaterials 2017 MS	CuCrO <sub>2</sub>	Mg	0.03	5.10E-1	-	2.73	1.17E22	-	329	0.175	-	-
	CuCrO <sub>2</sub>	-	-	8.47E-5	3	-	-	-	-	-	-	83
	CuCrO <sub>2</sub>	Fe	0.05	9.09E-5	2.87	-	-	-	-	-	-	-
	CuCrO <sub>2</sub>	Fe	0.01	1.00E-4	3.05	-	-	-	-	-	-	-
I. Kaya J. Mater. Sci.: Mater Electron. 2015 HT	CuCrO <sub>2</sub>	Fe	0.03	1.56E-4	3.09	-	-	-	-	0.0925	-	89
	CuCrO <sub>2</sub>	Mg	0.01	1.06E-3	3.01	-	-	-	-	-	-	-
	CuCrO <sub>2</sub>	Mg	0.05	4.55E-3	3.07	-	-	-	-	-	-	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
I. Kaya J. Mater. Sci.: Mater Electron. 2015 HT	CuCrO <sub>2</sub>	Mg	0.03	1.47E-2	3.06	-	-	-	-	0.0454	-	91
J. Cr�pelli�re J. Mater. Chem. C 2016 CVD	CuCrO <sub>2</sub>	-	-	1.70E+1	3.1	-	9E21	0.01	110	0.063	150	50
	CuCrO <sub>2</sub>	-	-	2.90E-3	3.4	-	-	-	-	-	-	-
J.H.L. Monteiro Ceram. Int. 2018 Comb.	CuCrO <sub>2</sub>	Mg	0.005	9.00E-1	3.3	-	-	-	-	-	-	-
	CuCrO <sub>2</sub>	Ag; Mg	0.007; 0.005	1.60E0	3.4	-	-	-	-	-	-	-
J. Afonso J. Mater. Sci.: Mater. Electron. 2018 CVD	CuCrO <sub>2</sub>	-	-	2.00E+1	3.2	-	2E21	-	-	-	250	-
L. Farrel J. Mater. Chem. C 2016 Spray	CuCrO <sub>2</sub>	-	-	1.20E+1	-	-	1.20E22	0.006	76	0.065	90	55
M. Ahmadi Appl. Phys. A 2018 MS	CuCrO <sub>2</sub>	-	-	5.50E-4	3.08	-	5.23E16	0.063	-	-	95	82
	CuCrO <sub>2</sub>	-	-	1.43E-3	3.01	-	8.98E17	0.673	-	-	150	53

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
M. Ahmadi Appl. Phys. A 2018 MS	CuCrO <sub>2</sub>	-	-	4.75E-3	2.94	-	3.42E18	0.866	-	-	130	62
	CuCrO <sub>2</sub>	-	-	1.89E-2	3	-	1.47E19	0.8	-	-	120	73
M. Ahmadi Appl. Phys. Lett. 2018 MS	CuCrO <sub>2</sub>	-	-	1.00E-2	3.38	-	3.4E17	2.2	-	-	150	66
	CuCrO <sub>2</sub>	-	-	1.30E0	3.42	-	5.4E19	0.173	-	-	150	69
	CuCrO <sub>2</sub>	Mg	0.05	5.20E0	3.2	-	1.3E20	0.011	-	-	150	64
	CuCrO <sub>2</sub>	Mg	0.025	1.04E+1	3.25	-	3.1E20	0.18	-	-	150	66
	CuCrO <sub>2</sub>	Mg	0.05	1.04E+2	3.6	-	9.1E20	0.023	-	-	150	67
M. J. Han J. Appl. Phys. 2013 SG	CuCrO <sub>2</sub>	Mg	0.025	2.78E+2	3.52	-	1.18E21	0.006	-	-	150	69
	CuCrO <sub>2</sub>	-	-	8.80E-4	3.14	2.79	1.42E15	3.89	-	0.292	-	70-75



First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G</sub> D (eV)	E <sub>G</sub> I (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
M. J. Han J. Appl. Phys. 2013 SG	CuCrO <sub>2</sub>	Mg	0.02	2.37E-	3.11	2.77	1.36E17	1.09	-	0.187	-	70-75
	CuCrO <sub>2</sub>	Mg	0.04	8.32E-1	3.1	2.75	2.11E19	0.25	-	0.087	320	70-75
	CuCrO <sub>2</sub>	Mg	0.06	2.03E0	3	2.56	3.29E19	0.39	-	0.07	-	70-75
	CuCrO <sub>2</sub>	Mg	0.08	2.21E0	3.02	2.58	4.07E20	0.03	-	0.055	-	70-75
	CuCrO <sub>2</sub>	Mg	0.1	2.94E0	3.04	2.64	8.73E20	0.02	-	0.047	-	70-75
	CuCrO <sub>2</sub>	Mg	0.12	3.85E0	3.06	2.66	8.66E20	0.03	-	0.042	-	70-75
M. O'Sullivan J. Phys. Conf. Ser. 2010 PLD	CuCrO <sub>2</sub>	Mg	0.1	6.67E+1	-	-	1E22	0.042	-	0.003	135	-
M. Han J. Alloys Compd. 2015 SG	CuCrO <sub>2</sub>	-	-	4.90E-3	3.1	-	2.15E15	14.1	-	0.003	239	-
	CuCrO <sub>2</sub>	-	-	1.10E-3	3.08	-	1.34E15	5.28	-	0.219	240	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
M. Han J. Alloys Compd. 2015 SG	CuCrO <sub>2</sub>	-	-	4.00E-4	3.06	-	1.22E15	2.43	-	0.283	242	-
P. L. Popa Appl. Mater. Today 2017 CVD	CuCrO <sub>2</sub>	-	-	7.00E-4	3.17	-	-	-	410	0.19	150	55
	CuCrO <sub>2</sub>	-	-	1.02E+2	3.2	-	1.5E21	0.33	87	0.06	150	45
P. L. Popa Thin Solid Films 2016 CVD	CuCrO <sub>2</sub>	-	-	5.00E-3	2.91	-	3E18	-	647	0.283	120	-
	CuCrO <sub>2</sub>	-	-	4.00E-2	3.07	-	3.2E20	-	249	0.158	200	-
	CuCrO <sub>2</sub>	-	-	4.50E-2	3.05	-	7.6E20	-	172	0.095	50	-
	CuCrO <sub>2</sub>	-	-	5.00E-2	3.16	-	4.8E20	-	213	-	120	-
P. L. Popa Thin Solid Films 2016 CVD	CuCrO <sub>2</sub>	-	-	3.00E-1	3.18	-	5.6E20	-	200	0.1	70	-
	CuCrO <sub>2</sub>	-	-	4.90E-1	3.21	-	9.2E20	-	155	0.09	70	-



First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
P. L. Popa Sci. Rep. 2018 CVD	CuCrO <sub>2</sub>	-	-	1.20E+1	-	-	-	0.004	100	-	-	-
	CuCrO <sub>2</sub>	-	-	1.70E+1	-	-	1.5E21	0.07	110	-	-	-
	CuCrO <sub>2</sub>	-	-	1.90E+1	-	-	9.4E16	0.086	947	-	-	-
	CuCrO <sub>2</sub>	-	-	2.10E+1	-	-	7.3E19	0.0001	374	-	-	-
	CuCrO <sub>2</sub>	-	-	2.30E+1	-	-	9.3E17	0.007	753	-	-	-
	CuCrO <sub>2</sub>	-	-	3.10E+1	-	-	2.9E20	0.002	257	-	-	-
P. Mandal Curr. Appl Phys. 2021 SS	CuCrO <sub>2</sub>	Li	0.015	5.00E-2	-	-	4.77E14	65.51	-	0.2194	-	-
	CuCrO <sub>2</sub>	Li	0.0124	2.00E-2	3.51	-	5.32E15	23.5	-	0.2266	-	-
P. Mandal J. Phys. D: Appl. Phys. 2016 SG	CuCrO <sub>2</sub>	Mg	0.05	2.20E-2	3.45	-	2.23E15	61.7	-	0.0547	-	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
P. Mandal J. Phys. D: Appl. Phys. 2016 SG	CuCrO <sub>2</sub>	Mg	0.05	4.50E-2	3.48	-	1.73E16	16.26	-	0.068	-	-
R. Nagarajan J. Appl. Phys. 2001 MS	CuCrO <sub>2</sub>	-	-	1.00E0	3.1	-	-	-	-	-	250	30
	CuCrO <sub>2</sub>	Mg	0.05	2.20E+2	3.1	2.75	-	-	153	0.02	250	30
R. Nagarajan Int. J. Inorg. Mater. 2001 SS	CuCrO <sub>2</sub>	Mg	0.05	7.70E-2	-	-	-	-	-	-	-	-
	CuCrO <sub>2</sub>	-	-	3.50E-5	-	-	-	-	-	-	-	-
R.I. Sánchez-Alarcón J. Phys. D : Appl. Phys. 2016 Spray	CuCrO <sub>2</sub>	-	-	3.50E+1	3.17	-	1E21	-	119	0.09	100-200	51
RS. Yu Coatings 2016 SG	CuCrO <sub>2</sub>	-	-	3.00E-2	3.09	-	1.1E15	-	-	-	165	40
	CuCrO <sub>2</sub>	Zn	0.18	5.00E-2	3.09	-	8.8E15	-	-	-	165	50
	CuCrO <sub>2</sub>	Zn	0.26	2.60E-1	3.1	-	1.8E17	-	-	-	165	50

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G</sub> D (eV)	E <sub>G</sub> I (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
RS. Yu Coatings 2016 SG	CuCrO <sub>2</sub>	Zn	0.44	2.50E-1	3.11	-	1.7E17	-	-	-	165	50
RS. Yu Appl. Surf. Sci. 2016 MS	CuCrO <sub>2</sub>	-	-	1.22E-1	3.12	-	6.05E17	1.22	-	-	-	67
	CuCrO <sub>2</sub>	-	-	2.32E-1	3.14	-	4.17E18	0.33	-	-	-	62
S. Götzendörfer Thin Solid Films 2009 SG	CuCrO <sub>2</sub>	-	-	1.67E-2	-	-	-	-	-	202	280	32
S. Mahapatra Chem. Vap. Deposition 2003 CVD	CuCrO <sub>2</sub>	-	-	8.60E-1	3.08	2.63	4.75E17	11.16	-	0.108	390	40-50
T. S. Tripathi Physics Procedia 2015 ALD	CuCrO <sub>2</sub>	-	-	1.00E0	3.09	-	-	-	300-325	-	125	74-79
T. S. Tripathi Adv. Electron. Mater. 2017 ALD	CuCrO <sub>2</sub>	Mg	0.025	2.17E+2	3	-	2.17E20	-	120	0.186	120-150	70
TW. Chiu Ceram. Int. 2012 CSD	CuCrO <sub>2</sub>	Mg	0.05	1.40E-1	3.08	-	1E18	0.7	-	-	195	70
	CuCrO <sub>2</sub>	Mg	0.05	2.80E-1	3.1	-	8E18	0.2	-	-	197	50

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
TW. Chiu Ceram. Int. 2012 CSD	CuCrO <sub>2</sub>	Mg	0.05	3.13E0	3.1	-	5E19	0.7	-	-	195	70
	CuCrO <sub>2</sub>	-	-	8.30E0	-	-	-	-	-	-	50	65
U. Sidik J. Nanosci. Nanotechnol. 2015 PLD	CuCrO <sub>2</sub>	Mg	0.02	1.64E+1	-	-	-	-	-	-	50	-
	CuCrO <sub>2</sub>	Mg	0.02	2.96E+1	3.22	-	-	-	-	-	50	60
X. Zhou J. Alloys. Compd. 2014 PLD	CuCrO <sub>2</sub>	-	-	4.80E0	3.13	-	3.13E19	0.97	-	0.169	130	67
	CuCrO <sub>2</sub>	Mn	0.05	1.70E-2	3.06	-	1.63E17	0.64	-	0.191	130	66
	CuCrO <sub>2</sub>	Mn	0.1	8.00E-3	3.04	-	6.59E16	0.76	-	0.256	130	64
	CuCrO <sub>2</sub>	Mn	0.15	8.00E-2	3.16	-	1.26E17	4.12	-	0.195	130	70
Y. Wang J. Sol-Gel Sci. Technol. 2011 SG	CuCrO <sub>2</sub>	-	-	1.35E-2	3.25	-	1E17	-	-	-	89	60

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
Y. Wang J. Sol-Gel Sci. Technol. 2011 SG	CuCrO <sub>2</sub>	Mn	0.05	9.43E-6	3.22	-	1E17	-	-	-	89	60
	CuCrO <sub>2</sub>	Mn	0.1	8.62E-6	3.18	-	1E17	-	-	-	89	60
Y. Wang J. Alloys. Compd. 2011 SG	CuCrO <sub>2</sub>	-	-	1.84E-2	3.15	2.8	3.14E15	6.75	266	-	103	75
	CuCrO <sub>2</sub>	Mg	0.03	2.75E-2	3.12	2.77	2.53E16	3.47	202	-	107	68
	CuCrO <sub>2</sub>	Mg	0.05	1.36E-1	3.11	2.76	3.14E18	2.13	180	-	113	66
	CuCrO <sub>2</sub>	Mg	0.07	1.97E-2	3.1	2.75	6.23E15	6.12	248	-	105	65
K. Isawa Phys. Rev. B: Condens. Matter 1997 SS	CuEuO <sub>2</sub>	-	-	3.01E-1	-	-	-	-	-	-	-	-
A. Barnabé, Mater Lett, 2006 MS	CuFeO <sub>2</sub>	-	-	1.03E-3	2	-	-	-	-	-	30	70
A. Wuttig, J. Mater. Chem. A, 2016 SS	CuFeO <sub>2</sub>	-	-	1.00E-1	-	-	8E15	90	-	0.053	-	-



First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G</sub> D (eV)	E <sub>G</sub> I (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
A. Wuttig, J. Mater. Chem. A, 2016 SS	CuFeO <sub>2</sub>	Mg (Cu)	0.005	2.00E-1	-	-	2.2E16	50	-	-	-	-
	CuFeO <sub>2</sub>	Mg (Cu)	0.02	2.00E-1	-	-	2E18	60	-	-	-	-
	CuFeO <sub>2</sub>	Mg	0.0005	1.00E0	-	-	8E18	1	-	0.034	-	-
	CuFeO <sub>2</sub>	Mg	0.005	2.00E0	-	-	1E18	10	-	-	-	-
	CuFeO <sub>2</sub>	Mg	0.02	6.00E0	-	-	1E17	400	-	0.021	-	-
C. Rudradawong Physica B 2017 SS	CuFeO <sub>2</sub>	-	-	3.60E0	3.6	2.6	-	-	-	0.049	-	-
C. Ruttanapun J. Alloys Compd. 2011 SS	CuFeO <sub>2</sub>	-	-	3.50E0	-	-	1.56E18	8.6	261	0.049	-	-
	CuFeO <sub>2</sub>	Pt (Cu)	0.01	5.00E0	-	-	3.86E18	6	249	0.046	-	-
	CuFeO <sub>2</sub>	Pt (Cu)	0.03	8.00E0	-	-	8.08E18	4.5	242	0.033	-	-

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C. Ruttanapun J. Alloys Compd. 2011 SS	CuFeO <sub>2</sub>	Pt (Cu)	0.05	1.10E1	-	-	4.04E19	1.8	240	0.028	-	-
D. B. Rogers Inorg. Chem. 1971 SS	CuFeO <sub>2</sub>	-	-	2.00E0	-	-	-	-	-	0.05	-	-
	CuFeO <sub>2</sub>	-	-	1.53E0	-	-	-	0.27	544	-	-	-
	CuFeO <sub>2</sub>	Sn	0.01	3.19E-3	-	-	-	1.1E-6	-415	-	-	-
F.A. Benko J. Phys. Chem. Solids 1987 SS	CuFeO <sub>2</sub>	Sn	0.05	2.4E-4	-	-	-	2.7E-6	-318	-	-	-
	CuFeO <sub>2</sub>	Mg	0.02	9.01E0	-	-	-	0.17	359	-	-	-
	CuFeO <sub>2</sub>	Mg	0.05	8.93E0	-	-	-	0.12	330	-	-	-
	CuFeO <sub>2</sub>	Mg	0.08	6.13E0	-	-	-	0.06	304	-	-	-
HY. Chen Thin Solid Films 2012 SG	CuFeO <sub>2</sub>	-	-	2.80E-1	3.05	-	1.2E18	1.42	330	0.14	90	50

<b>First Author</b>	<b>Journal</b>	<b>Year</b>	<b>Synthesis Method</b>	<b>Material</b>	<b>Dop.</b>	<b>Dop. level</b>	<b><math>\sigma</math> (S cm<sup>-1</sup>)</b>	<b>E<sub>G D</sub> (eV)</b>	<b>E<sub>G I</sub> (eV)</b>	<b>n (cm<sup>-3</sup>)</b>	<b><math>\mu</math> (cm<sup>2</sup>V<sup>-1</sup>s<sup>-1</sup>)</b>	<b>S (<math>\mu</math>V/K)</b>	<b>E<sub>act</sub> (V)</b>	<b>t (nm)</b>	<b>T (%)</b>	
HY. Chen	Thin Solid Films	2012	SG	CuFeO <sub>2</sub>	-	-	3.60E-1	3.05	-	5.3E18	0.7	315	0.11	90	50	
R. Nagarajan	Int. J. Inorg. Mater.	2001	SS	CuFe <sub>0.5</sub> V <sub>0.5</sub> O <sub>2</sub>	-	-	4.8E-6	-	-	-	-	-	-	-	-	
F.A. Benko	Phys. Status Solidi A	1986	SS	CuGaO <sub>2</sub>	Ca	0.05	5.56e-3	-	1.19	-	0.015	790	-	-	-	
H. Kawazoe	MRS Bull.	2000	PLD	CuGaO <sub>2</sub>	-	-	6.30E-2	3.6	-	1.7E18	0.23	560	-	500	80	
J. Tate	Thin Solid Films	2002	MS	CuGaO <sub>2</sub>	-	-	2.00E-2	4.3	-	-	-	360	0.1	150	70-85	
				CuGaO <sub>2</sub>	Fe	0.5	1.00E0	3.4	-	-	-	500	0.1	150	50-70	
M. Han	J. Mater. Chem.	2012	SG	CuGaO <sub>2</sub>	-	-	1.70E-2	3.56	3.24	2.93E16	3.37	-	0.21	-	-	
				CuGaO <sub>2</sub>	Cr	0.1	3.30E-2	-	-	9.56E16	2.15	-	-	-	-	-
				CuGaO <sub>2</sub>	Cr	0.2	7.10E-2	3.34	2.88	2.25E17	1.92	-	0.175	-	-	60

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
M. Han J. Mater. Chem. 2012 SG	CuGaO <sub>2</sub>	Cr	0.4	1.30E-2	3.28	2.83	2.84E16	2.79	-	0.222	-	-
	CuGaO <sub>2</sub>	Cr	0.6	2.40E-3	3.18	2.78	7.29E15	2.18	-	0.252	-	-
	CuGaO <sub>2</sub>	Cr	0.8	1.70E-3	3.13	2.72	2.19E15	5.05	-	0.284	-	-
N. Ashmore J. Mater. Sci. 2005 SS	CuGaO <sub>2</sub>	-	-	5.70E-3	-	-	-	-	-	0.21	-	-
	CuGaO <sub>2</sub>	-	-	6.90E-3	-	-	-	-	-	0.22	-	-
	CuGaO <sub>2</sub>	-	-	7.10E-3	-	-	-	-	-	0.21	-	-
	CuGaO <sub>2</sub>	-	-	1.10E-2	-	-	-	-	-	0.21	-	-
N. Ashmore J. Mater. Sci. 2005 SS	CuGaO <sub>2</sub>	-	-	1.40E-2	-	-	-	-	-	0.2	-	-
	CuGaO <sub>2</sub>	-	-	1.40E-2	-	-	-	-	-	0.18	-	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G</sub> D (eV)	E <sub>G</sub> I (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
N. Ashmore J. Mater. Sci. 2005 SS	CuGaO <sub>2</sub>	-	-	1.60E-2	-	-	-	-	-	0.2	-	-
	CuGaO <sub>2</sub>	-	-	1.60E-2	-	-	-	-	-	0.21	-	-
B. Yang Mater. Res. Soc. Symp. Proc. 2005 MS	CuInO <sub>2</sub>	-	-	5.60E-2	3.7	-	1.6E19	0.2	-	-	-	70
B. G. Nair Mater. Sci. Eng., B 2020 OPERE	CuInO <sub>2</sub>	Al	0.02	2.25E0	3.29	-	1.28E19	1.09	-193.9	-	-	-
	CuInO <sub>2</sub>	Al	0.07	3.68E0	3.05	-	1.12E18	20.4	5.7	-	-	-
	CuInO <sub>2</sub>	Al	0.12	3.45E0	3.01	-	5.84E17	37.28	53.4	-	-	-
C. W. Teplin Appl. Phys. Lett. 2004 PLD	CuInO <sub>2</sub>	Ca	0.05	3.00E-3	4.15	-	-	-	472	-	1000	-
H. Yanagi Appl. Phys. Lett. 2001 PLD	CuInO <sub>2</sub>	Ca	0.07	2.80E-3	3.9	-	-	-	480	0.19	170	70
	CuInO <sub>2</sub>	Sn	0.05	3.80E-3	3.9	-	-	-	-50	0.077	280	70

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	$E_G$ D (eV)	$E_G$ I (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	$E_{act}$ (V)	t (nm)	T (%)
K. Isawa Phys. Rev. B: Condens. Matter 1997 SS	CuLaO <sub>2</sub>	-	-	1.35E-1	-	-	-	-	-	-	-	-
G. Dong J. Phys. Chem. Solids 2012 SS	CuNdO <sub>2</sub>	-	-	2.70E-2	3.14	-	1.38E17	1.24	-	-	-	-
K. Isawa Phys. Rev. B: Condens. Matter 1997 SS	CuNdO <sub>2</sub>	-	-	1.35E0	-	-	-	-	-	-	-	-
J. Tate Thin Solid Films 2002 MS	CuNi <sub>2/3</sub> Sb <sub>1/3</sub> O <sub>2</sub>	Sn	0.1	5.00E-2	3.4	-	-	-	250	0.7	150-200	60
K. Isawa Phys. Rev. B: Condens. Matter 1997 SS	CuPrO <sub>2</sub>	-	-	3.68E-1	-	-	-	-	-	-	-	-
H. Kuriyama The 25th Proceedings of the International Conference on Thermoelectrics, Vienna, Austria 2006 SS	CuRhO <sub>2</sub>	Mg	0.1	1.67E+2	-	-	-	-	270	-	-	-
B. J. Ingram Chem. Mater. 2004 SS	CuScO <sub>2</sub>	-	-	3.70E-1	-	-	4.5E19	0.05	-	0.22	-	-
	CuScO <sub>2</sub>	Mg	0.05	2.28E0	-	-	4.48E20	0.03	-	0.25	-	-

First Author Journal Year Synthesis Method	Material	Dop.	Dop. level	$\sigma$ (S cm <sup>-1</sup> )	E <sub>G D</sub> (eV)	E <sub>G I</sub> (eV)	n (cm <sup>-3</sup> )	$\mu$ (cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> )	S ( $\mu$ V/K)	E <sub>act</sub> (V)	t (nm)	T (%)
J. Tate Thin Solid Films 2002 MS	CuScO <sub>2</sub>	Mg	0.05	2.00E1	3.3-3.6	-	-	-	-	-	250	15
R. Nagarajan Int. J. Inorg. Mater. 2001 MS	CuScO <sub>2</sub>	-	-	3.00E1	3.3	-	-	-	-	-	110	40
Y. Kakehi J. Appl. Phys. 2005 PLD	CuScO <sub>2</sub>	-	-	1.08E-7	3.7	-	-	-	-	-	135	75
	CuScO <sub>2</sub>	Mg	0.1	2.50E-1	3.7	-	-	-	10	0.27	124	65
Y. Kakehi Thin Solid films 2003 PLD	CuScO <sub>2</sub>	-	-	1.20E-4	3.7	-	-	-	-	-	-	70
Y. Kakehi J. Cryst. Growth 2009 PLD	CuScO <sub>2</sub>	-	-	1.00E-3	3.7	-	4.5E16	0.14	968	0.62	250	60
K. Isawa Phys. Rev. B: Condens. Matter 1997 SS	CuSmO <sub>2</sub>	-	-	4.97E-1	-	-	-	-	-	-	-	-
B. J. Ingram Chem. Mater. 2004 SS	CuYO <sub>2</sub>	-	-	1.80E-2	-	-	2.6E18	0.04	-	0.23	-	-
	CuYO <sub>2</sub>	Ca	0.05	2.60E-1	-	-	3.3E19	0.05	-	0.28	-	-







## Table S II

Compilation of Cu-Cr-O delafossite properties reported in literature (organized after methods and reports). The methods are separated using by thicker border lines, the references are separated by thinner border lines. Some reports contain sets of data, depending on the deposition conditions or various post-treatments

On the columns are depicted the followings:

**Methods:** The used abbreviations: ALD - Atomic Layer Deposition; CSD – Chemical Solution Deposition; **Dopant:** The chemical symbol of the dopant. For the Nitrogen (N,) the processes are described as in the presence of Nitrogen (as no detection of N in the films thereafter). For deposition methods using target the method used for target synthesis is underlined (SG- Solid Gel, SS - Solid State). **Level of the dopant.** The minus sign corresponds to a mentioned deficit. The gaseous percentages) are referring mostly to the deposition process (as “reactive” gases). ND – non doped phase. Generally, the articles mentioned first measure for non-doped material and then the measures for altered phases. Within a report, the non-doped data are separated by a double thin border line. **Electrical conductivity;** Room temperature data are presented; **Activation energy:** Mixed values for mobility and conduction activation are presented. **Carrier Concentration; Electric Mobility:** The H subscript refers to values measures by Hall effect. The underlined values indicate values calculated by us using  $\sigma = ne\mu$  (if conductivity and concentrations are presented); **Optical transmission; Seebeck coefficient; Direct or/and Indirect Band Gap; Thickness; The reference within the article**

Method	Dopant	Level of doping	Cond (RT) (S/m <sup>-1</sup> )	Activ Energy (eV)	Concentration cm <sup>-3</sup>	mobility cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup>	Seebeck coef. $\mu$ V K <sup>-1</sup>	T (%)	Band gap (eV)		Thick (nm)	REF
									Direct	Indirec <sub>t</sub>		
SOL GEL	ND	-	0.0009	0.292	1.421E+15	3.89 <sup>H</sup>			3.14	2.79		
		0.02	0.0237	0.187	1.36E+17	1.09 <sup>H</sup>			3.11	2.77		
		0.04	0.832	0.087	2.11E+19	0.25 <sup>H</sup>			3.1	2.75		
		0.06	2.03	0.07	3.29E+19	0.39 <sup>H</sup>	70-75		3	2.56	320	181
		0.08	2.21	0.055	4.07E+20	0.03 <sup>H</sup>			3.02	2.58		
		0.1	2.94	0.047	8.73E+20	0.02 <sup>H</sup>			3.04	2.64		
		0.12	3.85	0.042	8.66E+20	0.03 <sup>H</sup>			3.06	2.66		
		-	0.038		1.70E+17	0.96			3			
		ND	-	0.02		1.30E+17	1.4	60-75			180	185
			-	0.023		1.90E+17	0.76					
			-	0.0048								
		ND						<50	3.16	2.7		
									3.16	2.66	88	186
									3.15	2.62		
		ND	-	0.017				202	40		280	184
		ND	-	0.15		1.70E+18	0.56 <sup>H</sup>	20	47	3	190	
		Zn	0.01	0.26		2.15E+18	0.76 <sup>H</sup>	40	50	3.05	220	182
			0.03	0.47		3.20E+18	0.92 <sup>H</sup>	113	55	3.05	205	
		ND	-	0.0006	0.321	2.90E+14	14.3 <sup>H</sup>		60-80	3.09	2.72	251
		Ga	0.2	0.0017	0.284	2.19E+15	5.05 <sup>H</sup>		60-80	3.13	2.78	254
	0.4		0.0024	0.252	7.29E+15	2.18 <sup>H</sup>		60-80	3.18	2.83	242	
	ND		0.0011	0.285	2.80E+14	25		45-55	2.95			
		0.05	0.0032		3.80E+15	5.3		45-55	2.85	190		
	Cr def	0.1	0.0044	0.275	5.90E+15	4.7		60	3.05		180	
		0.2	0.16	0.18	1.80E+16	56		60	3.08	210		
	ND		0.018	0.301	3.14E+15	6.75	266	65-70	3.15	2.8	103	
		0.03	0.027	0.275	2.53E+16	3.47	202	60	3.12	2.77	107	
	Mg	0.05	0.14	0.18	3.14E+18	2.13	180	60	3.11	2.76	113	187
		0.07	0.2	0.306	6.23E+15	6.12	248	60	3.1	2.75	115	

	ND	0	0.03		1.09E+15	<u>172.02</u>	<50	3.09		
		0.025	0.05		8.80E+15	<u>35.51</u>	<50	3.09		
	Zn	0.065	0.26		1.88E+17	<u>8.64</u>	<50	3.1	165	247
		0.085	0.25		1.67E+17	<u>9.36</u>	<50	3.11		
	ND							3.52		
	Mg	0.05	0.022	0.055	2.20E+15	61.7		3.45		
	S	0.1						3.5		242
	Mg+S	0.05+ 0.1	0.045	0.068	1.70E+16	16.3		3.48		
	ND		0.001	0.28				1100		
		0.005	0.05	0.17				600		
	Mg	0.01	0.1	0.17				390		144
		0.02	1.25	0.19				260		
	ND		0.004	0.278				350		
		0.005	0.67	0.119		0.034				
		0.01	1.21	0.095		0.031				
	Mg	0.02	8.33	0.036		0.11				142
		0.03	15.62	0.026		0.13				
		0.04	11		8.70E+20	0.085	50			
	ND		0.001	0.29						
		0.02	0.01	0.24						
	Ni	0.04	0.03	0.23						233
		0.06	0.047	0.23						
	ND	0.03	0.85	0.351			950	3.1		
		0.01		0.41						
	Sn	0.03		0.407						246
	ND				1.00E+17		1600			
	Mg	0.03	1		1.10E+19		200			
	Ca	0.03	0.05		5.00E+18		800			237
	Sr	0.03	0.05		3.00E+18		750			
	Ba	0.03			3.00E+17		900			
	ND						3.35	1.28		177

SOLID STATE

PULSED LASER DEPOSITION

ND									
<u>SG</u>	0.25	0.52			60-80	3.2		90	189
ND									
<u>SS</u>	4.76	0.169	3.13E+19	0.97	55	3.13			
	0.05	0.017	0.191	1.60E+17		3.06			243
Mn	0.1	0.008	0.256	6.59E+16		3.04			
	0.15	0.08	0.195	1.26E+17		3.16			
ND									
<u>SS</u>	0.11	1.79	1.40E+18	<u>7.7</u>	<60	3.17		26	
	0.05	2.53	0.067	2.52E+18		<u>6.27</u>	<50	3.12	36
Fe	0.1	5.55	0.064	6.51E+18		<u>5.32</u>	<50	3.08	38
	0.15	27.8	0.04	4.09E+19		<u>4.2</u>	<50	3.05	52
		0.015					55	3.2	57
ND							60	3.2	127
<u>SG</u>		0.33					60	3.2	134
		0.011					60	3.2	134
ND									
<u>SG</u>		0.067	0.147				60	3.2	134
	0.02	0.4	0.032				60	3.2	127
Mg	0.05	0.025	0.019					3.2	57
ND									
<u>SS</u>							60	3.2	63
	0.05						65	3.1	27
Mg	0.1	25		1.00E+22	0.042			3.2	135
ND									
<u>SS</u>		8.3					65	3.2-	50
								3.2	
Mg	0.02	16.35							
Mg+	0.02+						60		50
V <sub>Cr</sub>	0.03	29.63							
ND									
<u>SS</u>		0.0002		5.10E+14				3.25	
	0.01	0.01		2.50E+15				3.24	
Ni	0.03	0.0125		1.90E+16			<50	3.24	204
	0.05	0.1		2.30E+17				3.22	

	Mg	0.05	220			150	30	3.1	1.45	250	117
	<u>SS</u>										
	Mg	0.03	0.002		5.90E+17	2.53	804				
	<u>SS</u>										
		0.03	17.76	0.055	1.09E+21	0.074	140				
		0.03	64.27	0.055	1.42E+21	0.103	116				
	Mg	0.03	52.82	0.063	1.34E+21	0.155	121				196
		0.03	37.78	0.063	1.32E+21	0.182	122	<50	3.3	300	
		0.03	52.16		1.18E+21	0.163	133				
		0.03	34.6		8.07E+20	0.408	167				
	ND		0.38		1.19E+19	0.19		60-65	3.18		
	ND		0.42		1.43E+19	0.18		<50	3.17	100	203
	ND										
	<u>SS</u>		0.08	0.035	4.50E+18	0.11			3.05		
	N gas	0.1	0.018	0.035	8.70E+18	0.14		<40	3.07	300	210
	N gas	0.2	0.11	0.035	3.00E+19	0.25			3.13		
	N gas	0.3	1.7	0.035	1.40E+20	0.81			3.19		
			0.057		1.00E+17	0.2					
	Mg	0.05	0.17		2.50E+18	0.25			3.2	135	202
	<u>SS</u>		0.4		6.00E+18	0.4					
		Dual	0.19		4.00E+18	0.3		58		167	
	ND	Cu	0.17		3.80E+18	0.29		52		171	201
		Cr	0.09		3.40E+18	0.18		37		213	
			0.04		2.63E+18	0.09		18		315	
	ND	0 0	0.01		3.40E+17	2.2		66	3.38		
	<u>SS</u>										
	N		1.3		5.40E+19	0.173		69	3.42		
	Mg	0.025	10.4		3.10E+20	0.018		66	3.25		
	Mg+	0.025	278		1.20E+21	0.006		69	3.52	150	47
	N	+ N									
	Mg	0.05	5.2		1.30E+20	0.011		64	3.2		
	Mg+	0.05+	104		9.10E+20	0.023		67	3.6		
	N	N									
	Mg	0.03	0.6	0.175	1.17E+20		329		2.73	300	257
	<u>SS</u>										
	Mg	0.05	0.28		1.00E+19	0.2		50		197	238
			3.13		5.00E+19	0.7		70	3.1	195	

CSD



